



Docket No.: 8733.977.00  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:

LEE, Yun Bok et al.

Customer No.: 30827

Application No.: 10/736,677

Confirmation No.: 4107

Filed: December 17, 2003

Art Unit: 2881

For: ION BEAM IRRADIATION DEVICE

Examiner: Kalimah Fernandez

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated June 15, 2005, please amend the patent application identified above as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.